



10-03-05

DPW \$ CC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Attorney Docket: SLA0696

Inventor: Jong-Jan Lee, et al.

Confirmation No. 8265

Serial No.: 10/625,065

Group #: 1763

Filed: July 22, 2003

Examiner: George A. Goudreau

Title: FABRICATION OF SILICON-ON-NOTHING (SON) MOSFET
FABRICATION USING SELECTIVE ETCHING OF $\text{Si}_{1-x}\text{Ge}_x$ LAYER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

ASSOCIATE POWER OF ATTORNEY

CHANGE OF CORRESPONDENCE ADDRESS

I hereby appoint Robert D. Varitz, of 4915 S.E. 33rd Place, Portland, Oregon 97202, U. S. Patent and Trademark Office Registration Number 31436, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please change the correspondence address to that associated with Customer Number 55376.

Date: 8/4/05

Respectfully submitted,

David C. Ripma
David C. Ripma, Registration # 27,672

David C. Ripma Patent Counsel
Sharp Laboratories of America, Inc.
5750 N.W. Pacific Rim Highway
Camas, WA 98607
Phone: (360) 834-8754
Facsimile: (360) 817-8505